

Practitioner's Docket No.: 811_106

**AFTER FINAL
PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Takao SAITO, Yukinori NAKAMURA, Yoshimasa KONDO
and Naoto OHTAKE

Ser. No.: 10/774,454

Group Art Unit: 1792

Filed: February 10, 2004

Examiner: David P. Turocy

Confirmation No.: 9153

For: THIN FILMS AND A METHOD FOR PRODUCING THE SAME

Mail Stop A.F.
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF EFS TRANSMISSION

I hereby certify that this paper is being transmitted via EFS to
the Patent and Trademark Office on *February 17, 2009*.

Christina M. Bersani
Christina M. Bersani

REQUEST FOR RECONSIDERATION

DO NOT ENTER: /D.T./

Sir:

03/20/2009

In response to the Office Action mailed October 17, 2008, Applicants respectfully request reconsideration and withdrawal of the rejections of record based on the following arguments.

Claims 1-3 and 5-9 are pending herein. The PTO has withdrawn claims 5-7 from further consideration.

Claims 1-3 and 9 were rejected under §103(a) over Yara alone or in view of Hartmann or Awazu, and claims 1-4, 8 and 9 were rejected under §103(a) over Yara in view of Mizuno. These rejections are respectfully traversed.

Claim 1 recites a method of producing a thin film using opposing electrodes, the method including a step of applying a pulse voltage on the opposing electrodes under a